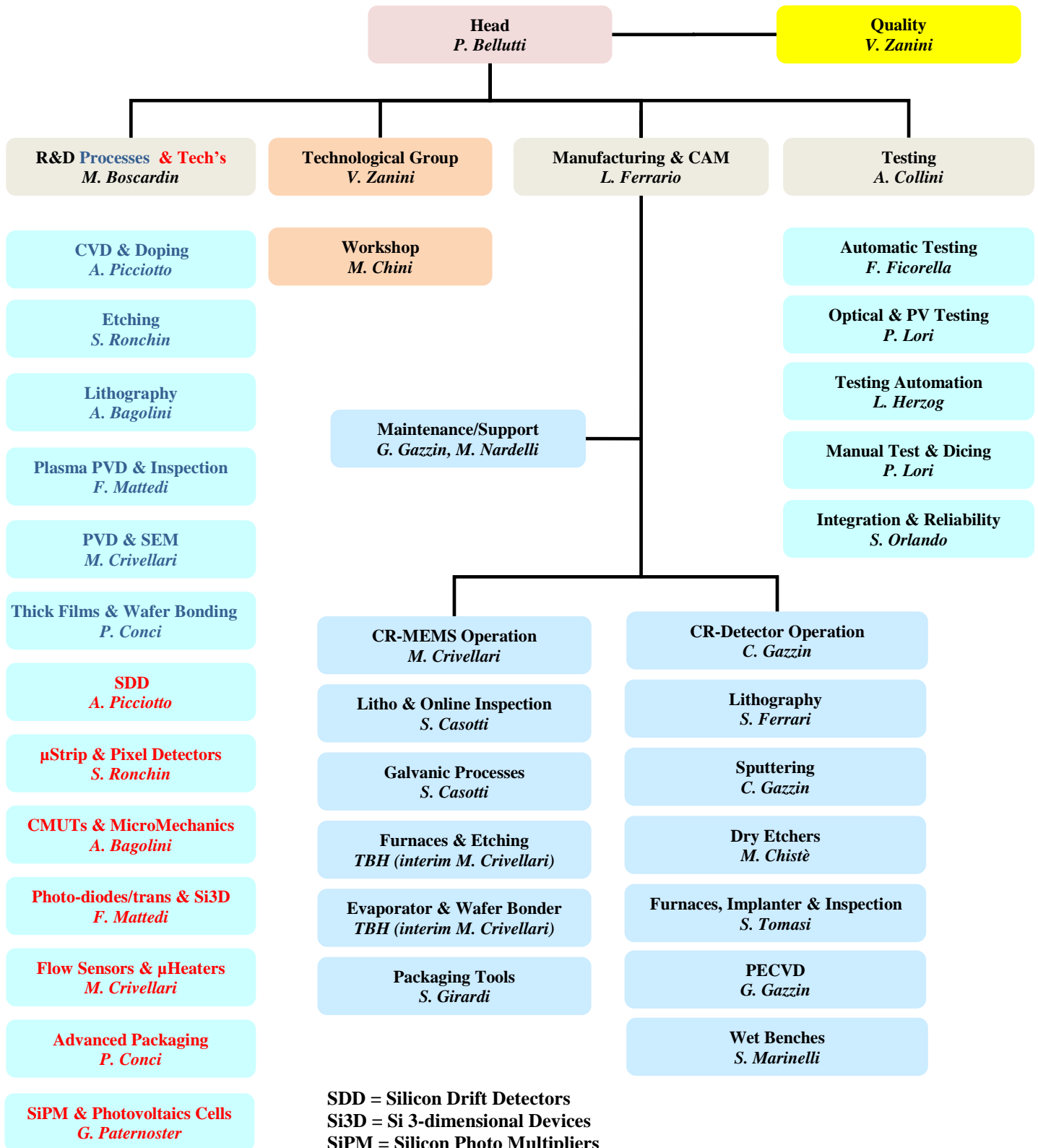


# MTLab Organizational Chart



**SDD = Silicon Drift Detectors**  
**Si3D = Si 3-dimensional Devices**  
**SiPM = Silicon Photo Multipliers**  
**CMUT = Capacitive Micromachined Ultrasonic Transducers**  
**PV = Photovoltaics**  
**PVD = Physical Vapour Deposition**  
**CVD = Chemical vapour Deposition**  
**SEM = Scanning Electron Microscopy**  
**CAM = Computer Aided manufacturing**  
**CR = Clean Room**  
**MEMS = Micro-Electro-Mechanical Systems**